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<b>DATE:</b>	August 18, 2004	<b>PAGES:</b>	<u>11 (eleven) w/cover</u>
<b>TO:</b>	Examiner Steven Ho Yin Loke GAU 2811	<b>PHONE:</b>	(571) 272- 1657
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**Message**

**DOCKET No. : GS 152 Div**

Please see attached: Amendment

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PATENT APPLICATION  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Iuan Hshich et al.  
Application No. 10/725,325  
Filed: December 1, 2003  
Title: Trench MOSFET Device with Improved On-Resistance  
Art Unit: 2811  
Examiner: Steven Loke  
Docket No.: GS 152 Div

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated May 18, 2004, please consider the following amendment(s) and response: